Docket No.: 21776-00042-US1 (PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Nobuhiro Miki et al.

Application No.: 10/656,190 Confirmation No.: 8417

Filed: September 8, 2003 Art Unit: 1746

For: SURFACE PURIFICATION APPARATUS AND

SURFACE PURIFICATION METHOD

Examiner: M. Kornakov

RESPONSE TO RESTRICTION REQUIREMENT

MS Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In response to the restriction requirement set forth in the Office Action mailed August 30, 2006, Applicant hereby provisionally elects claims 11-13 and 18 for continued examination.

The Examiner has required restriction between claims 1-5 and 8, drawn to a surface purification apparatus and claims 11-13 and 18, drawn to a surface purification method.

Applicant believes no fee is due with this response. However, if a fee is due, please charge our Deposit Account No. 22-0185, under Order No. 21776-00042-US1 from which the undersigned is authorized to draw.

Dated: September 29, 2006 Respectfully submitted,

Electronic signature: /Myron Keith Wyche/ Myron Keith Wyche, Reg. No. 47,341 CONNOLLY BOVE LODGE & HUTZ LLP 1990 M Street, N.W., Suite 800 Washington, DC 20036 (202) 331-7111 (202) 293-6229 (Fax) Attorney for Applicant